

00684.003654

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
 : Examiner: Unassigned
 TAKAKO YAMAGUCHI ET AL.)
 : Group Art Unit: 1756
 Application No.: 10/529,891)
 :
 Entry into U.S. National)
 Stage Under 35 U.S.C. § 371: April 1, 2005 :
)
 For: EXPOSURE MASK, METHOD OF DESIGNING:
 AND MANUFACTURING THE SAME,)
 EXPOSURE METHOD AND APPARATUS, :
 PATTERN FORMING METHOD, AND DEVICE)
 MANUFACTURING METHOD : June 22, 2005

MAIL STOP AMENDMENT

Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Prior to examination on the merits, please amend the above-identified application as
 follows: